



10-27-04

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EXPRESS MAIL mailing label No. EV 374 589 565 US Date of Deposit October 25, 2004

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/ Ruth Montalvo Date: 10/25/04

Docket No.:GK-ZEI-3214/500343.20225

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Customer No. 26418  
Applicant: Hans-Juergen Dobschal et al  
Serial No.: 10/626,130  
Filed: July 24, 2003  
For: IMAGING SYSTEM FOR A MICROSCOPE BASED ON  
EXTREME ULTRAVIOLET (EUV) RADIATION

**AMENDMENT**

Commissioner for Patents  
P.O Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to an Office Action dated July 23, 2004, please amend the above-identified application as follows.